



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 40296-0029

Applicant(s): Jung Taik Cheong et al

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Art Unit: 2813

Title: METHOD FOR FORMING A SEMICONDUCTOR DEVICE WITH A  
HARD MASK LAYER FORMED OVER A BIT LINE TO PROTECT  
THE BIT LINE DURING SUBSEQUENT ETCHING STEPS

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Sir:

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Respectfully submitted,

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